

<b>Notice of References Cited</b>	Application/Control No. 10/676,692	Applicant(s)/Patent Under Reexamination HEBRINK ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,641,900	11-2003	Hebrink et al.	428/212
	C	US-6,111,697	08-2000	Merrill et al.	359/497
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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